

FORM PTO-1390 (REV. 11-2000)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTORNEY'S DOCKET NUMBER Mic.6222
TRANSMITTAL LETTER TO THE UNITED STATES DESIGNATED/ELECTED OFFICE (DO/EO/US) CONCERNING A FILING UNDER 35 U.S.C. 371			U.S. APPLICATION NO. (If known, see 37 CFR 1.5) 09/857285
INTERNATIONAL APPLICATION NO. PCT/EP99/09882	INTERNATIONAL FILING DATE 14 December 1999	PRIORITY DATE CLAIMED 19 December 1998	
TITLE OF INVENTION SENSOR			
APPLICANT(S) FOR DO/EO/US Günter IGEL, Ulrich SIEBEN, Jürgen GIEHL			
Applicant herewith submits to the United States Designated/Elected Office (DO/EO/US) the following items and other information:			
<ol style="list-style-type: none"> 1. <input checked="" type="checkbox"/> This is a FIRST submission of items concerning a filing under 35 U.S.C. 371. 2. <input type="checkbox"/> This is a SECOND or SUBSEQUENT submission of items concerning a filing under 35 U.S.C. 371. 3. <input checked="" type="checkbox"/> This is an express request to begin national examination procedures (35 U.S.C. 371(f)). The submission must include items (5), (6), (9) and (21) indicated below. 4. <input checked="" type="checkbox"/> The US has been elected by the expiration of 19 months from the priority date (Article 31). 5. <input checked="" type="checkbox"/> A copy of the International Application as filed (35 U.S.C. 371(c)(2)) <ol style="list-style-type: none"> a. <input checked="" type="checkbox"/> is attached hereto (required only if not communicated by the International Bureau). b. <input type="checkbox"/> has been communicated by the International Bureau. c. <input type="checkbox"/> is not required, as the application was filed in the United States Receiving Office (RO/US). 6. <input checked="" type="checkbox"/> An English language translation of the International Application as filed (35 U.S.C. 371(c)(2)). <ol style="list-style-type: none"> a. <input checked="" type="checkbox"/> is attached hereto. b. <input type="checkbox"/> has been previously submitted under 35 U.S.C. 154(d)(4). 7. <input checked="" type="checkbox"/> Amendments to the claims of the International Application under PCT Article 19 (35 U.S.C. 371(c)(3)) <ol style="list-style-type: none"> a. <input checked="" type="checkbox"/> are attached hereto (required only if not communicated by the International Bureau). b. <input type="checkbox"/> have been communicated by the International Bureau. c. <input type="checkbox"/> have not been made; however, the time limit for making such amendments has NOT expired. d. <input type="checkbox"/> have not been made and will not be made. 8. <input checked="" type="checkbox"/> An English language translation of the amendments to the claims under PCT Article 19 (35 U.S.C. 371 (c)(3)). 9. <input type="checkbox"/> An oath or declaration of the inventor(s) (35 U.S.C. 371(c)(4)). 10. <input checked="" type="checkbox"/> An English language translation of the annexes of the International Preliminary Examination Report under PCT Article 36 (35 U.S.C. 371(c)(5)). 			
Items 11 to 20 below concern document(s) or information included:			
<ol style="list-style-type: none"> 11. <input checked="" type="checkbox"/> An Information Disclosure Statement under 37 CFR 1.97 and 1.98. 12. <input type="checkbox"/> An assignment document for recording. A separate cover sheet in compliance with 37 CFR 3.28 and 3.31 is included. 13. <input checked="" type="checkbox"/> A FIRST preliminary amendment. 14. <input type="checkbox"/> A SECOND or SUBSEQUENT preliminary amendment. 15. <input checked="" type="checkbox"/> A substitute specification. 16. <input type="checkbox"/> A change of power of attorney and/or address letter. 17. <input type="checkbox"/> A computer-readable form of the sequence listing in accordance with PCT Rule 13ter.2 and 35 U.S.C. 1.821 - 1.825. 18. <input type="checkbox"/> A second copy of the published international application under 35 U.S.C. 154(d)(4). 19. <input type="checkbox"/> A second copy of the English language translation of the international application under 35 U.S.C. 154(d)(4). 20. <input checked="" type="checkbox"/> Other items or information: - Copy of International Preliminary Examination Report in German 			

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Nigel et al. **GROUP:** Not yet assigned
INTERNATIONAL APPLN. NO.: PCT/EP99/09882 **EXAMINER:** Not yet assigned
SERIAL NO: Not yet assigned
INTERNATIONAL FILING DATE: 14 December 1999
FOR: SENSOR

FIRST PRELIMINARY AMENDMENT

Entry of this preliminary amendment is respectfully requested.

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Preliminary to calculation of the filing fee, please amend the above-identified application as follows:

09/857285

Micronas.6222

JC18 Rec'd PCT/PTO 31 MAY 2001

Marked-up copy of the specification

JC18 Rec'd PCT/PTO 31 MAY 2001

SENSOR**BACKGROUND OF THE INVENTION**

A capacitive sensor for both absolute and relative pressure measurements is known from the DE 33 10 643. This sensor has a first and second electrode, which are at a distance from one another and which form a measurement capacitance. The first electrode is disposed on a first substrate body and the second electrode on a second substrate body. These substrate bodies are laterally connected to one another, and the second substrate body in the region of the second electrode is constructed as a diaphragm which can be deformed by pressure. The capacitive output signals of the sensor are conducted to an external evaluation unit and are evaluated there.

The U.S. Patent- A-5,635,919 discloses a multipurpose sensor which likewise is used to measure distances, index of refraction, voltages, elongations, force, torque, temperature, pressure, magnetic and electric field strength, and other physical variables. This sensor has a signal source, affixed to a first substrate, to create a modulated signal, a receiver, which is affixed on a second substrate at a fixed or variable distance to the signal source, an evaluation circuit with an amplifier to evaluate the signal, and a control unit to control the signal source. The computer unit first calculates the signal delay, for which obviously some information regarding the transmitted signal must already be previously known and consequently stored and updated in the computer unit. From this, the desired physical quantity is determined.

For example, to measure the temperature, a gas at constant pressure is used as the transmission medium between the signal source and the receiver. The density of this gas then likewise changes with changing temperature.

A sensor with a different structure is described in the WO-A-97/42478. A light source as a signal source and a receiver as a signal detector, together with an evaluation and control unit, are integrated on a semiconductor chip. The light source or the receiver can be designed as a diaphragm, whose position is changed in dependence on the pressure exerted on them.

~~The a US_A 5 689 107 U.S. Patent 5,689,107~~ gain-discloses a different sensor for measuring force, acceleration, and pressure with a light source and a plurality of spatially distributed receivers for the spatially resolved measurement of the distance of the arm and of the desired physical quantity in an evaluation unit, such as for example e.g. a force, an acceleration, or a pressure.

~~The US-A 4 478 076 U.S. Patent 4,478,076~~ discloses a throughflow sensor, in which thin-layer conductor tracks are used as heating elements or as several spatially distributed temperature sensors. An evaluation and control circuit is situated below these thin-layer elements.

A problem with these sensor devices is their relatively high power consumption.

Therefore, is a need for a relatively low power/efficient sensor device.

~~It is the object of the invention to create a sensor whose structure has the broadest possible application, which delivers the most accurate measurement results possible, and which nevertheless is distinguished by very little power consumption.~~

~~This object is achieved by a sensor with the characteristics given in Claim 1.~~
~~Advantageous further developments of the sensor are presented in the subclaims~~

SUMMARY OF THE INVENTION

Through the inventive measure, namely by means of the control unit to operate the evaluation unit and supplementary thereto also the signal detector only for the time during which

reception and evaluation of an emitted physical signal from the signal source is expected, the power consumption of the sensor is greatly reduced over a longer period of time, which again opens up a widened field of application in remote measurement stations, especially without connection to an electrical network.

The inventive sensor includes[has] a signal source thattø emits a physical signal and a signal detector which is independent of the signal source and which is situated at a distance therefrom. The signal detector receives the physical signal ~~where the detector is located~~, after the physical signal has traversed the space between the signal source and the signal detector and has ~~thereby been effected by the characteristics of the space~~changed. The signal received ~~by~~in the signal detector is conducted to an evaluation unit, which evaluates the received signal with the help of stored information about the signal source and thus about the emitted physical signal. The evaluation preferably includes a comparison of the expected signal, in terms of information about the signal source and thus about the emitted signal, with the actually received signal. Information is thus gained about the relative distance, that is a variable which is determined on the one hand by the spatial distance between the signal source and the signal detector and on the other hand also by the transmission properties of the region between the signal source and the signal detector. This relative distance thus must be distinguished from the purely geometrical distance of the signal source from the signal detector.

Through this type of interaction, if the geometric distance is known, information can be obtained about a change of the transmission behavior. From this, certain physical properties, such as density changes, temperature changes, or changes of the transport speed, or a change of the throughflow quantity or also their absolute values can be determined. On the other hand, if the transmission conditions are constant, information can be obtained about the change of the

geometrical distance between the signal source and the signal detector. If the distance change is caused by an external force, a pressure, or an acceleration or the like, the change of these variables or their absolute values can be determined from this. Because the signal source and the signal detector are mutually independent and separate units, which ideally are not even connected electrically or electronically, it is possible to avoid mutual influences, such as are known in connection with the capacitive sensor of the DE 33 10 643, where these mutual influences result from the two electrodes which form a measurement capacitance.

Among the large number of physical signals, radioactive signals, electromagnetic signals, optical signals, pressure variations, or thermal signals have proven to be especially suitable physical signals. By constructing the signal source and the signal detector on a common substrate or on two separate, closely spaced substrates, the sensor dimensions can be greatly reduced. This greatly extends the possible field of application of such a sensor, for example in the pharmaceutical industry or the chemical industry, where one deals with very high-grade or expensive substances with small volumes.

It has proven especially advantageous to keep the distance between the signal source and the signal detector constant, especially by a self-enclosed, mechanically rigid structure of one or more substrates, and thereby make it possible to detect and evaluate changes in the transmission properties in the spatial region between the signal source and the signal detector. Such a sensor is especially suited to measure changes in the gas density or in the transport speed or in the throughflow quantity or in the temperature distribution, or the absolute values thereof.

It also proves to be especially advantageous to keep the transmission properties constant in the region between the signal source and the signal detector, and thereby make it possible to measure the distance between the signal source and the signal detector or its change. The

transmission properties are here kept constant especially in that the space between the signal source and the signal detector has a uniform and permanent structure. Care must especially be taken to keep the temperature constant, to keep the composition constant, and to make the space isotropic, as well as similar variables. It has proven especially advantageous to fill the space completely with a noble gas or still better with a vacuum. In this case, by comparing the received signal with the information about the emitted signal, information can be obtained about the distance and its change.

A preferred embodiment of the invention comprises a control unit which is connected to the signal source and controls it. Furthermore, ~~t~~The control unit is also connected to the evaluation unit, thus updating the information about the signal source for the purpose of evaluating the received physical signals. Furthermore, ~~it is possible, by means of this the control unit may, to~~ operate the evaluation unit and, as a supplement to this, also the signal detector only for the time during which reception and evaluation of an emitted physical signal by the signal source is expected. This design makes it possible to reduce significantly the electrical consumption of the sensor over an extended period of time, which again opens up a greater field of application, especially in remote measurement stations and especially without a connection to an electrical network.

The evaluation unit and/or the control unit preferably is disposed in the substrate body or bodies, especially in the region of the signal source or of the signal detector, thus achieving a higher integration density of the sensor and smaller size. ~~This very advantageously affects the size of the sensor.~~ Furthermore, such an arrangement proves electronically ~~very~~ advantageous, since ~~very~~ short signal paths can be realized thereby and thus only minimal signal losses can occur, leading to an especially advantageous signal-to-noise ratio for the received physical signal.

Furthermore, such an arrangement proves insensitive to external electronic noise influences, for example through the constantly present electromagnetic smog, which is especially important for application in the automotive field. Such a sensor, with an electronic evaluation unit and/or control unit integrated into the substrate body thus proves especially suitable for use in the automotive field. The control unit preferably is implemented in the substrate body separately from the evaluation unit. The control unit preferably is arranged in the region of the signal source, especially below this, while the evaluation unit is arranged in the substrate body in the region of the signal detector and especially below this. If the signal source and the signal detector are constructed separately on separate substrate bodies, this separation will also be realized for the control unit and the evaluation unit. This most thoroughly excludes mutual interference of the electronic units.

It has proven especially advantageous for the evaluation unit to have one or more signal-amplifying elements in the substrate body. By the arrangement in the substrate, especially below the signal detector, they can make an optimal contribution, since ~~it is precisely the short signal paths that yields~~ a very good signal-to-noise ratio and thus a good resolution. This arrangement proves to be an especially suited design of the inventive sensor.

According to another embodiment of a sensor, in which the distance between the signal source and the signal detector is variable, the substrate body is designed as a diaphragm in the region of the signal receiver and/or the substrate body in the region of the signal detector. It changes its position due to an external force, ~~or due to an external pressure, or due to an~~ acceleration of the sensor, and thereby changes the distance between the signal source and the signal detector. This allows a measurement of the externally acting force, ~~or the pressure or the~~ acting acceleration, or their changes. Thus, in a manner that is simple in its production

engineering and that is sparing in its use of space, a universally suited sensor can be created for the measurement of forces, pressures, or accelerations, or the like.

Preferably, a sensor with a diaphragm has an additional damping device to damp undesirable vibrations, thus yielding measurement results of substantially better quality, since interference with the measurement values by undesirable vibrations, especially due to resonances in the sensor (~~and~~ especially in the region of the diaphragm), can be excluded by such a damping device. For example, such damping devices can be formed by reinforcements in the region of the diaphragm, whereby the resonance frequencies of the diaphragm can be moved into specific, less troublesome regions, or its tendency to vibrate can be markedly reduced. Furthermore, it has proven advantageous to fill ~~up~~ the closed volume of the sensor in the region of the diaphragm with a gas of higher density to, ~~and thereby~~ achieve better damping. ~~It has also turned out appropriate to damp~~ The region of the diaphragm may also be damped by a magnetic force, by disposing one or more magnets at suitable points around the diaphragm and equipping the diaphragm itself with an appropriate magnet. The magnetic interaction of these magnets causes the diaphragm to take up its equilibrium position faster and thus acts as a damping mechanism.

According to a preferred embodiment of the invention, the signal source and/or the signal detector are constructed in such a way that they are suited for space-resolving measurements. This can be done by the signal detector having spatially separated segments, which are activated by the physical signal in a spatially differentiated way, and which are evaluated in a spatially differentiated way by an appropriate electronic apparatus for the space-resolving processing of the received physical signals. This apparatus for space-resolving processing preferably is disposed within the substrate body, and especially below the signal detector in the region of the evaluation unit. This leads to advantages comparable to those of the arrangement of the evaluation unit in the

substrate body. This space-resolving measurement and evaluation makes it possible to obtain specific information about the type of excursion of the diaphragm, its mechanical condition, especially its fatigue state, and thus the possibility of healing the diaphragm and the sensor arrangement. This sensor therefore proves to be one which detects failure due to material fatigue of the diaphragm at an early stage and provides the user with the information that replacement of the inventive sensor is necessary.

A sensor in which the physical signal consists of includes electromagnetic radiation has proven especially advantageous. Here, the signal source and/or the signal detector is realized by an antenna that includes consisting of conductor tracks on or in the substrate body. It is thus possible to create a complete sensor by an all-through production process of the substrate body, with the electrical conductor tracks implemented thereon or therein, and with electronic apparatuses, without additional, separate, other production processes, and without the additional attachment of separately produced signal sources or signal detectors. This sensor therefore proves economical and very simple to produce, and reliable. ~~as regards its production engineering, also very economical, as well as very little prone to trouble.~~ This makes this sensor very suitable for mass production, for example in the automotive field or also for use under extreme conditions, where there is an extraordinary need for quality.

The control unit of the sensor is preferably ~~is~~ connected to the signal source and to the evaluation unit such that the current properties of the signal source are taken into account in the evaluation and thus in the comparison of the emitted physical signal and the expected physical signal with the actually received physical signals. If a change of the properties of the signal source results in a change of the emitted physical signal, for example by a diminished activity of a radioactive radiation source, this information is made available by ~~means of~~ the connecting line of

respect to the location of the individual signal detector elements, and thus an evaluation with respect to the spatial development of the physical signal. This leads to a representation of the throughflow quantity through the spatial region 6 between the signal source 3 and the signal detector 4.

The signal source 3 shown in this embodiment is a thermal source. If the intermediate space 6 between the signal source 3 and the signal detector 4 is traversed by a slowly flowing fluid, the thermal energy is deflected only slightly in the flow direction; at a higher flow rate, it is deflected more strongly. Depending on the measure of deflection, various signal detector elements are excited, from which a conclusion can be drawn concerning the flow rate of the substance traversing the space 6, and from this a measurement of the throughflow quantity can also be gained.

In this embodiment, the signal source 3 operates completely independently of the signal detector 4 and of the evaluation unit 5. Consequently, it is also not necessary to connect the signal detector 3 electrically to the signal detector 4 or to the evaluation unit 5. This is especially advantageous since it essentially excludes all problems associated with sealing electrical connections against the flowing measurement substance, and thus excludes the risk of malfunction or total failure of the sensor.

The construction of the sensor with the two substrate bodies 1, 2 and the signal source 3 and signal detector 4, together with the integrated evaluation unit 5, situated thereon create an extremely small sensor structure. It can thus also be used in situations where, for example, only small amounts of substance are present, whose throughflow rate or throughflow quantity is to be measured. Such a throughflow quantity sensor proves to be especially suitable for the

pharmaceutical industry or for test laboratories, prototype laboratories and analytical laboratories of the chemical industry.

FIG. 2 illustrates ~~shows an inventive a~~ pressure sensor 200 that includes comprising a first substrate body 1 and a second substrate body 2, such that a signal detector 4 is situated on the second substrate body 2 and an electronic evaluation unit 5 is integrated into the second substrate body 2, so as to process the physical measurement signals. Integrating the evaluation device 5 into the substrate body 2 directly at the signal detector 4 utilizes the available space for the entire sensor very efficiently. Furthermore, the signal paths from the signal detector 4 to the evaluation unit 5 are considerably shortened, resulting in an especially reliable evaluation of the measurement signals. The first substrate body 1 is formed in such a way that it has a diaphragm which can be deformed by pressure. Usually the pressure is exerted on the membrane in the direction of the arrow. A signal source 3 is situated in the area of the diaphragm, on that side which is associated with the signal detector 4. If the diaphragm is deformed through the action of an external pressure, the signal source 3 is thereby changed in its position, and this causes its distance from the signal detector 4 to change. If the physical signal emitted by the signal source 3 has a dependence on the distance it traverses before being received by the signal detector 4, information about the traversed path and thus about the distance between the signal source 3 and the signal detector 4 can be obtained from the evaluation of the received physical signal by the evaluation unit 5. Information thus can be obtained about the pressure exerted on the diaphragm. This information can relate both to the relative pressure and absolute pressure.

In onethe-chosen embodiment, the substrate bodies 1, 2 are made of silicon. This makes integration of the evaluation unit 5 especially simple. In addition, silicon has especially advantageous mechanical properties for the deformable diaphragm 5. The signal source 3 and the

signal detector 4 are formed on their respective substrate bodies 1, 2, by conductor tracks with a specific shape and size so that on the one hand they act as a transmission antenna and on the other hand as a reception antenna for an appropriate electromagnetic signal. The electromagnetic signal can be specified by the shape and size of the corresponding conductor tracks, so that the influences of interfering external electromagnetic fields can be reduced to a minimum. As described before, the received electromagnetic signal depends on the transmission properties of the space 6 between the signal source 3 and the signal detector 4, the spacing being especially and centrally important. If the space is filled by a homogeneous substance, which is non-specific in its electromagnetic transmission properties except for the transmission path, this design of the sensor proves to be especially suitable, for example, to measure exactly the pressure on the diaphragm. If, in addition to the dependence of the transmission properties on the transmission path, there exists a dependence on temperature, this temperature dependence can be taken into account in the evaluation by the evaluation unit 5 through the use of a well-known thermometer. In such a case, however, this sensor inversely can also be used as a temperature sensor, if the distance between the signal source 3 and the signal detector 4 is held constant or can be determined in another way.

FIG. figure 3 is a block diagram illustration of a sensor embodiment. ~~shows an exemplary circuit diagram of an inventive sensor.~~ The sensor includes It shows the transmission source 3, which is separated from the signal detector 4 by the spatial region 6. The signal source 3 transmits a physical signal in the direction of the signal detector 4. This signal is indicated by the arrow B and traverses the spatial region 6.

The sensor has a control unit 7, which is connected to the transmission source 3 by a control line, and actuates said transmission source to emit a certain physical signal at a specific time. Furthermore, the control unit 7, which preferably is integrated in the substrate body 1 close

to the signal source 3, is connected to the signal detector 4. The evaluation unit 4 is integrated into the second substrate body 2, which is associated with the signal detector 4. By means of the connecting lines to the signal detector 4 and to the evaluation unit 5, these are switched on specifically in knowledge of the control data of the signal source and the expected reception time of the physical signal. This ensures ~~guarantees~~ that the signal detector 4 ~~will detect~~s the physical signal emitted by the signal source 3 and that the evaluation unit 5 will make an appropriate evaluation. Outside this time window, necessary for reliable operation, the signal detector 4 or also the evaluation unit 5 is turned off, thus significantly reducing the energy consumption of the sensor over time. The like also holds for the signal source 3.

The evaluation unit 5 is connected to the control unit 7 and the signal detector 4, through which connection the received physical signal is conducted to the evaluation unit 5. However, it is also connected to an external display 98. The measurement variables measured by the evaluation unit 5, such as pressure, force, acceleration, throughflow rate, throughflow quantity, temperature, or the like, are displayed to the user on this display unit.

What is claimed is:

List of Reference Symbols

- 1——First substrate body
- 2——Second substrate body
- 3——Signal source
- 4——Signal detector
- 5——Evaluation unit
- 6——Spatial region
- 7——Control unit
- 8——Display

Clean Copy of the Specification
Following Entry of this Amendment

SENSOR

BACKGROUND OF THE INVENTION

A capacitive sensor for both absolute and relative pressure measurements is known from the DE 33 10 643. This sensor has a first and second electrode, which are at a distance from one another and which form a measurement capacitance. The first electrode is disposed on a first substrate body and the second electrode on a second substrate body. These substrate bodies are laterally connected to one another, and the second substrate body in the region of the second electrode is constructed as a diaphragm which can be deformed by pressure. The capacitive output signals of the sensor are conducted to an external evaluation unit and are evaluated there.

The U.S. Patent 5,635,919 discloses a multipurpose sensor which likewise is used to measure distances, index of refraction, voltages, elongations, force, torque, temperature, pressure, magnetic and electric field strength, and other physical variables. This sensor has a signal source, affixed to a first substrate, to create a modulated signal, a receiver, which is affixed on a second substrate at a fixed or variable distance to the signal source, an evaluation circuit with an amplifier to evaluate the signal, and a control unit to control the signal source. The computer unit first calculates the signal delay, for which obviously some information regarding the transmitted signal must already be previously known and consequently stored and updated in the computer unit. From this, the desired physical quantity is determined.

For example, to measure the temperature, a gas at constant pressure is used as the transmission medium between the signal source and the receiver. The density of this gas then likewise changes with changing temperature.

A sensor with a different structure is described in the WO-A-97/42478. A light source as a signal source and a receiver as a signal detector, together with an evaluation and control unit, are integrated on a semiconductor chip. The light source or the receiver can be designed as a diaphragm, whose position is changed in dependence on the pressure exerted on them.

U.S. Patent 5,689,107 discloses a different sensor for measuring force, acceleration, and pressure with a light source and a plurality of spatially distributed receivers for the spatially resolved measurement of the distance of the arm and of the desired physical quantity in an evaluation unit, such as for example a force, an acceleration, or a pressure..

U.S. Patent 4,478,076 discloses a throughflow sensor, in which thin-layer conductor tracks are used as heating elements or as several spatially distributed temperature sensors. An evaluation and control circuit is situated below these thin-layer elements.

A problem with these sensor devices is their relatively high power consumption.

Therefore, is a need for a relatively low power/efficient sensor device.

SUMMARY OF THE INVENTION

Through the inventive measure, namely by means of the control unit to operate the evaluation unit and supplementary thereto also the signal detector only for the time during which reception and evaluation of an emitted physical signal from the signal source is expected, the power consumption of the sensor is greatly reduced over a longer period of time, which again opens up a widened field of application in remote measurement stations, especially without connection to an electrical network.

The inventive sensor includes a signal source that emits a physical signal and a signal detector which is independent of the signal source and which is situated at a distance therefrom.

The signal detector receives the physical signal after the physical signal has traversed the space between the signal source and the signal detector and has been effected by the characteristics of the space. The signal received by the signal detector is conducted to an evaluation unit, which evaluates the received signal with the help of stored information about the signal source and thus about the emitted physical signal. The evaluation preferably includes a comparison of the expected signal, in terms of information about the signal source and thus about the emitted signal, with the actually received signal. Information is thus gained about the relative distance, that is a variable which is determined on the one hand by the spatial distance between the signal source and the signal detector and on the other hand also by the transmission properties of the region between the signal source and the signal detector. This relative distance thus must be distinguished from the purely geometrical distance of the signal source from the signal detector.

Through this type of interaction, if the geometric distance is known, information can be obtained about a change of the transmission behavior. From this, certain physical properties, such as density changes, temperature changes, or changes of the transport speed, or a change of the throughflow quantity or also their absolute values can be determined. On the other hand, if the transmission conditions are constant, information can be obtained about the change of the geometrical distance between the signal source and the signal detector. If the distance change is caused by an external force, a pressure, or an acceleration or the like, the change of these variables or their absolute values can be determined from this. Because the signal source and the signal detector are mutually independent and separate units, which ideally are not even connected electrically or electronically, it is possible to avoid mutual influences, such as are known in connection with the capacitive sensor of the DE 33 10 643, where these mutual influences result from the two electrodes which form a measurement capacitance.

It has proven especially advantageous to keep the distance between the signal source and the signal detector constant, especially by a self-enclosed, mechanically rigid structure of one or more substrates, and thereby make it possible to detect and evaluate changes in the transmission properties in the spatial region between the signal source and the signal detector. Such a sensor is especially suited to measure changes in the gas density or in the transport speed or in the throughflow quantity or in the temperature distribution, or the absolute values thereof.

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A preferred embodiment of the invention comprises a control unit which is connected to the signal source and controls it. The control unit is also connected to the evaluation unit, thus updating the information about the signal source for the purpose of evaluating the received physical signals. Furthermore, the control unit may operate the evaluation unit and, as a supplement to this, also the signal detector only for the time during which reception and evaluation of an emitted physical signal by the signal source is expected. This design makes it possible to reduce significantly the electrical consumption of the sensor over an extended period of time, which again opens up a greater field of application, especially in remote measurement stations and especially without a connection to an electrical network.

The evaluation unit and/or the control unit preferably is disposed in the substrate body or bodies, especially in the region of the signal source or of the signal detector, thus achieving a higher integration density of the sensor and smaller size. Furthermore, such an arrangement proves electronically advantageous, since short signal paths can be realized thereby and thus only minimal signal losses can occur, leading to an especially advantageous signal-to-noise ratio for the received physical signal. Furthermore, such an arrangement proves insensitive to external electronic noise influences, for example through the constantly present electromagnetic smog, which is especially important for application in the automotive field. Such a sensor, with an electronic evaluation unit and/or control unit integrated into the substrate body thus proves especially suitable for use in the automotive field. The control unit preferably is implemented in the substrate body separately from the evaluation unit. The control unit preferably is arranged in the region of the signal source, especially below this, while the evaluation unit is arranged in the substrate body in the region of the signal detector and especially below this. If the signal source and the signal detector are constructed separately on separate substrate bodies, this separation will

also be realized for the control unit and the evaluation unit. This most thoroughly excludes mutual interference of the electronic units.

It has proven especially advantageous for the evaluation unit to have one or more signal-amplifying elements in the substrate body. By the arrangement in the substrate, especially below the signal detector, they can make an optimal contribution, since the short signal paths yields a very good signal-to-noise ratio and thus good resolution. This arrangement proves to be an especially suited design of the inventive sensor.

According to another embodiment of a sensor, in which the distance between the signal source and the signal detector is variable, the substrate body is designed as a diaphragm in the region of the signal receiver and/or the substrate body in the region of the signal detector. It changes its position due to an external force, an external pressure, or an acceleration of the sensor, and thereby changes the distance between the signal source and the signal detector. This allows a measurement of the externally acting force, pressure or acceleration, or their changes. Thus, in a manner that is simple in its production engineering and that is sparing in its use of space, a universally suited sensor can be created for the measurement of forces, pressures, or accelerations, or the like.

Preferably, a sensor with a diaphragm has an additional damping device to damp undesirable vibrations, thus yielding measurement results of substantially better quality, since interference with the measurement values by undesirable vibrations, especially due to resonances in the sensor (especially in the region of the diaphragm), can be excluded by such a damping device. For example, such damping devices can be formed by reinforcements in the region of the diaphragm, whereby the resonance frequencies of the diaphragm can be moved into specific, less troublesome regions, or its tendency to vibrate can be markedly reduced. Furthermore, it has

proven advantageous to fill the closed volume of the sensor in the region of the diaphragm with a gas of higher density to achieve better damping. The region of the diaphragm may also be damped by a magnetic force, by disposing one or more magnets at suitable points around the diaphragm and equipping the diaphragm itself with an appropriate magnet. The magnetic interaction of these magnets causes the diaphragm to take up its equilibrium position faster and thus acts as a damping mechanism.

According to a preferred embodiment of the invention, the signal source and/or the signal detector are constructed in such a way that they are suited for space-resolving measurements. This can be done by the signal detector having spatially separated segments, which are activated by the physical signal in a spatially differentiated way, and which are evaluated in a spatially differentiated way by an appropriate electronic apparatus for the space-resolving processing of the received physical signals. This apparatus for space-resolving processing preferably is disposed within the substrate body, and especially below the signal detector in the region of the evaluation unit. This leads to advantages comparable to those of the arrangement of the evaluation unit in the substrate body. This space-resolving measurement and evaluation makes it possible to obtain specific information about the type of excursion of the diaphragm, its mechanical condition, especially its fatigue state, and thus the possibility of healing the diaphragm and the sensor arrangement. This sensor therefore proves to be one which detects failure due to material fatigue of the diaphragm at an early stage and provides the user with the information that replacement of the inventive sensor is necessary.

A sensor in which the physical signal includes electromagnetic radiation has proven especially advantageous. Here, the signal source and/or the signal detector is realized by an antenna that includes conductor tracks on or in the substrate body. It is thus possible to create a

complete sensor by an all-through production process of the substrate body, with the electrical conductor tracks implemented thereon or therein, and with electronic apparatuses, without additional, separate, other production processes, and without the additional attachment of separately produced signal sources or signal detectors. This sensor therefore proves economical and simple to produce, and reliable. This makes this sensor suitable for mass production, for example in the automotive field or also for use under extreme conditions, where there is an extraordinary need for quality.

The control unit of the sensor is preferably connected to the signal source and to the evaluation unit such that the current properties of the signal source are taken into account in the evaluation and thus in the comparison of the emitted physical signal and the expected physical signal with the actually received physical signals. If a change of the properties of the signal source results in a change of the emitted physical signal, for example by a diminished activity of a radioactive radiation source, this information is made available by the connecting line of the electronic arrangement to the evaluation device (also called evaluation unit), and is taken into account in the evaluation. It is thus possible to take changes of the signal source into account automatically during the evaluation. This makes the measurement result of the sensor much more reliable.

DETAILED DESCRIPTION OF THE DRAWINGS

FIG. 1 illustrates a first inventive embodiment of the sensor with a radioactive signal source and a space-resolving signal detector to measure the throughflow quantity;

FIG. 2 illustrates a second inventive embodiment of the sensor configured as a pressure sensor; and

FIG. 3 is a block diagram illustration of a sensor embodiment.

DETAILED DESCRIPTION OF THE INVENTION

FIG. 1 illustrates a sensor 100 for throughflow measurements. The sensor 100 includes a first substrate body 1, associated with a second substrate body 2 situated at a distance. The signal source 3 is situated on the first substrate body 1 and faces the second substrate body 2. The signal detector 4 is situated on the second substrate body 2 and faces the first substrate body 1. It is divided into four individual, spatially separated detector elements 4a, 4b, 4c, 4d. An electronic evaluation unit 5 is situated in the interior of the second substrate body 2. It is connected to the individual signal detector elements 4a-4d, and it amplifies and evaluates the received physical signals. This evaluation also comprises a differentiation with respect to the location of the individual signal detector elements, and thus an evaluation with respect to the spatial development of the physical signal. This leads to a representation of the throughflow quantity through the spatial region 6 between the signal source 3 and the signal detector 4.

The signal source 3 shown in this embodiment is a thermal source. If the intermediate space 6 between the signal source 3 and the signal detector 4 is traversed by a slowly flowing fluid, the thermal energy is deflected only slightly in the flow direction; at a higher flow rate, it is deflected more strongly. Depending on the measure of deflection, various signal detector elements are excited, from which a conclusion can be drawn concerning the flow rate of the substance traversing the space 6, and from this a measurement of the throughflow quantity can also be gained.

In this embodiment, the signal source 3 operates independently of the signal detector 4 and of the evaluation unit 5. Consequently, it is also not necessary to connect the signal detector 3

electrically to the signal detector 4 or to the evaluation unit 5. This is especially advantageous since it essentially excludes all problems associated with sealing electrical connections against the flowing measurement substance, and thus excludes the risk of malfunction or total failure of the sensor.

The construction of the sensor with the two substrate bodies 1, 2 and the signal source 3 and signal detector 4, together with the integrated evaluation unit 5, situated thereon create an extremely small sensor structure. It can thus also be used in situations where, for example, only small amounts of substance are present, whose throughflow rate or throughflow quantity is to be measured. Such a throughflow quantity sensor proves to be especially suitable for the pharmaceutical industry or for test laboratories, prototype laboratories and analytical laboratories of the chemical industry.

FIG. 2 illustrates a pressure sensor 200 that includes a first substrate body 1 and a second substrate body 2, such that a signal detector 4 is situated on the second substrate body 2 and an electronic evaluation unit 5 is integrated into the second substrate body 2, so as to process the physical measurement signals. Integrating the evaluation device 5 into the substrate body 2 directly at the signal detector 4 utilizes the available space for the entire sensor very efficiently. Furthermore, the signal paths from the signal detector 4 to the evaluation unit 5 are considerably shortened, resulting in an especially reliable evaluation of the measurement signals. The first substrate body 1 is formed in such a way that it has a diaphragm which can be deformed by pressure. Usually the pressure is exerted on the membrane in the direction of the arrow. A signal source 3 is situated in the area of the diaphragm, on that side which is associated with the signal detector 4. If the diaphragm is deformed through the action of an external pressure, the signal source 3 is thereby changed in its position, and this causes its distance from the signal detector 4 to

change. If the physical signal emitted by the signal source 3 has a dependence on the distance it traverses before being received by the signal detector 4, information about the traversed path and thus about the distance between the signal source 3 and the signal detector 4 can be obtained from the evaluation of the received physical signal by the evaluation unit 5. Information thus can be obtained about the pressure exerted on the diaphragm. This information can relate both to the relative pressure and absolute pressure.

In one embodiment, the substrate bodies 1, 2 are made of silicon. This makes integration of the evaluation unit 5 especially simple. In addition, silicon has especially advantageous mechanical properties for the deformable diaphragm 5. The signal source 3 and the signal detector 4 are formed on their respective substrate bodies 1, 2, by conductor tracks with a specific shape and size so that on the one hand they act as a transmission antenna and on the other hand as a reception antenna for an appropriate electromagnetic signal. The electromagnetic signal can be specified by the shape and size of the corresponding conductor tracks, so that the influences of interfering external electromagnetic fields can be reduced.. As described before, the received electromagnetic signal depends on the transmission properties of the space 6 between the signal source 3 and the signal detector 4. If the space is filled by a homogeneous substance, which is non-specific in its electromagnetic transmission properties except for the transmission path, this design of the sensor proves to be especially suitable, for example, to measure the pressure on the diaphragm. If, in addition to the dependence of the transmission properties on the transmission path, there exists a dependence on temperature, this temperature dependence can be taken into account in the evaluation by the evaluation unit 5 through the use of a well-known thermometer. In such a case, however, this sensor inversely can also be used as a temperature sensor, if the

distance between the signal source 3 and the signal detector 4 is held constant or can be determined in another way.

FIG. 3 is a block diagram illustration of a sensor embodiment. The sensor includes the transmission source 3, which is separated from the signal detector 4 by the spatial region 6. The signal source 3 transmits a physical signal in the direction of the signal detector 4. This signal is indicated by the arrow B and traverses the spatial region 6. The sensor has a control unit 7, which is connected to the transmission source 3 by a control line, and actuates said transmission source to emit a certain physical signal at a specific time. Furthermore, the control unit 7, which preferably is integrated in the substrate body 1 close to the signal source 3, is connected to the signal detector 4. The evaluation unit 4 is integrated into the second substrate body 2, which is associated with the signal detector 4. By means of the connecting lines to the signal detector 4 and to the evaluation unit 5, these are switched on specifically in knowledge of the control data of the signal source and the expected reception time of the physical signal. This ensures that the signal detector 4 detects the physical signal emitted by the signal source 3 and that the evaluation unit 5 will make an appropriate evaluation. Outside this time window, necessary for reliable operation, the signal detector 4 or also the evaluation unit 5 is turned off, thus significantly reducing the energy consumption of the sensor over time. The like also holds for the signal source 3.

The evaluation unit 5 is connected to the control unit 7 and the signal detector 4, through which connection the received physical signal is conducted to the evaluation unit 5. However, it is also connected to an external display 8. The measurement variables measured by the evaluation unit 5, such as pressure, force, acceleration, throughflow rate, throughflow quantity, temperature, or the like, are displayed to the user on this display unit.

What is claimed is:

Clean Copy of the Claims
Following Entry of This Amendment

1 1.(amended) A sensor, comprising:

2 a signal source that emits a physical signal;

3 a signal detector at a distance from the signal source to receive the physical signal;

4 an evaluation unit which is connected to the signal detector and evaluates the received

5 physical signal to determine the relative distance between the signal source and the signal detector,

6 wherein the signal source and the signal detector are situated on separate substrate bodies;

7 a control unit is connected to the signal source, the signal detector , and the evaluation unit,

8 wherein the signal source, signal detector and the evaluation unit can each be individually turned

9 on and off the control unit.

1 2.(amended) The sensor of claim 1, wherein the evaluation unit includes a memory device having

2 characteristic information indicative of the signal source.

1 3.(amended) The sensor of claim 1, wherein the spatial distance between the signal source and

2 the signal detector is constant, and the transmission properties of the transmission channel between

3 the signal source and the signal detector are variable.

1 4.(amended) The sensor of claim 1, wherein the spatial distance between the signal source and

2 the signal detector is variable, and that the transmission properties of the transmission channel

3 between the signal source and the signal detector are constant.

1 5.(amended) The sensor of claim 3, wherein the evaluation unit is configured and arranged such
2 that the gas density or the transport rate or the throughflow quantity can be determined from the
3 relative distance.

1 6.(amended) The sensor of claim 4, wherein the evaluation unit is configured and arranged such
2 that the force acting on the sensor can be determined from the relative distance.

1 7.(amended) The sensor of claim 6, wherein the control unit is connected to the signal source and
2 controls it, and that the evaluation unit is connected to the control unit in such a way that the
3 information regarding the signal source can be updated with control data received from the control
4 unit.

1 8.(amended) The sensor of claim 1, wherein the evaluation unit and is integrated into at least
2 one of the substrate bodies.

1 9.(amended) The sensor of claim 8, wherein the evaluation unit is situated in the substrate body
2 directly adjoining the signal detector.

1 10.(amended) The sensor of claim 8, wherein the evaluation unit is integrated into the second
2 substrate body and the control unit is integrated into the first substrate body.

1 11.(amended) The sensor of claim 10, wherein the evaluation unit includes means for amplifying
2 the signal.

1 12.(amended) The sensor of claim 3, wherein the second substrate body, in which the signal
2 detector is situated includes a diaphragm.

1 13.(amended) The sensor of claim 12, further comprising a damping device to damp the
2 diaphragm.

1 14.(amended) The sensor of claim 1, wherein the signal detector is sub-divided into a plurality
2 detector elements sufficient to provide a measure of spatial resolution.

1 15.(amended) The sensor of claim 14, wherein said evaluation unit includes means for processing
2 the spatially resolved measurement.

1 16.(amended) The sensor of claim 15, wherein conductor tracks are situated in the respective
2 substrate is used to form the signal source.

REMARKS

Claims 1-16 have been amended. Claims 1-16 remain.

Examination on the merits is respectfully requested.

If a telephone interview could assist in the prosecution of this application, please call the undersigned attorney.

Respectfully submitted,

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VERSION WITH MARKINGS TO SHOW CHANGES MADE TO CLAIMS

1.(amended) A sensor, comprising:

a signal source (3) ~~to that~~ emits a physical signal;
~~and comprising~~ a signal detector (4) at a distance from the signal source (3) to receive the physical signal; ~~at the location of the signal detector, and comprising~~
an evaluation unit (5) which is connected to the signal detector (4) ~~and so as to~~ evaluates the received physical signal ~~and to~~ determine the relative distance between the signal source (3) and the signal detector (4), wherein such that the signal source (3) and the signal detector (4) are situated on a common substrate body (1) or on two separate substrate bodies (1, 2);
~~, characterized in that~~ a control unit (7) is connected to the signal source (3), the signal detector (4), and/or the evaluation unit (5), wherein the signal source, signal detector and the evaluation unit that these units individually or in arbitrary combination can each be individually be
turned on and off in a specific way by the control unit 7.

2.(amended) The sensor of Claim 1, wherein the evaluation unit includes a memory device having characteristic information indicative of the signal source, characterized in that the evaluation is performed by means of stored information regarding the signal source (3).

3.(amended) The sensor of Claim 1 or 2, wherein characterized in that the spatial distance between the signal source (3) and the signal detector (4) is constant, and that the transmission

properties of the transmission channel between the signal source (3) and the signal detector (4) are variable.

4.(amended) The sensor of Claim 1 or 2, wherein characterized in that the spatial distance between the signal source (3) and the signal detector (4) is variable, and that the transmission properties of the transmission channel between the signal source (3) and the signal detector (4) are constant.

5.(amended) The sensor of Claim 3, wherein characterized in that the evaluation unit (5) is configured and arranged such ~~designed in such a way~~ that the gas density or the transport rate or the throughflow quantity can be determined from the relative distance.

6.(amended) The sensor of Claim 4, wherein characterized in that the evaluation unit (5) is configured and arranged such ~~designed so that the acceleration, the pressure, or the force acting on~~ the sensor can be determined from the relative distance.

7.(amended) The sensor of claim 6, wherein ~~one of the preceding claims,~~ characterized in that the control unit (7) is connected to the signal source (3) and controls it, and that the evaluation unit (5) is connected to the control unit (7) in such a way that by means of the control data received from the control unit (7), the information regarding the signal source (3) can be updated with control data received from the control unit.

14.(amended) The sensor of claim 1, wherein the signal detector is sub-divided into a plurality of detector elements sufficient to provide a measure of ~~one of the preceding claims~~, characterized in that the signal source (3) and/or the signal detector (4) has a spatial structure apt to measure spatial resolution.

15.(amended) The sensor of claim 14, wherein said evaluation unit includes means for ~~characterized in that it has an electronic arrangement to processing~~ the spatially resolved measurement.

16.(amended) The sensor of claim 15, wherein ~~one of the preceding claims~~, characterized in that ~~part of the conductor tracks~~ are situated in the respective substrate is used to form the signal source, (3) and/or to form the signal detector (4).

Published

With International Search Report.

(54) Title: **SENSOR**

(57) Abstract [Already in English]

Description

Sensor

A capacitive sensor for both absolute and relative pressure measurements is known from the DE 33 10 643. This sensor has a first and second electrode, which are at a distance from one another and which form a measurement capacitance. The first electrode is disposed on a first substrate body and the second electrode on a second substrate body. These substrate bodies are laterally connected to one another, and the second substrate body in the region of the second electrode is constructed as a diaphragm which can be deformed by pressure. The capacitive output signals of the sensor are conducted to an external evaluation unit and are evaluated there.

It is the object of the invention to create a sensor whose structure offers the broadest possible fields of application.

This object is achieved by a sensor with the characteristics given in Claim 1. Advantageous further developments of the sensor are presented in the subclaims.

The inventive sensor has a signal source to emit a physical signal and a signal detector which is independent of the signal source and which is situated at a distance therefrom. The signal detector receives the physical signal where the detector is located, after the physical signal has traversed the space between the signal source and the signal detector and has thereby been changed. The signal received in the signal detector is conducted to an evaluation unit, which evaluates the received signal with the help of stored information about the signal source and thus about the emitted physical signal. The evaluation preferably

includes a comparison of the expected signal, in terms of information about the signal source

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Among the large number of physical signals, radioactive signals, electromagnetic signals, optical signals, pressure variations, or thermal signals have proven to be especially suitable physical signals. By constructing the signal source and the signal detector on a common substrate or on two separate, closely spaced

substrates, the sensor dimensions can be greatly reduced. This greatly extends the possible field of application of such a sensor, for example in the pharmaceutical industry or the chemical industry, where one deals with very high-grade or expensive substances with small volumes.

It has proven especially advantageous to keep the distance between the signal source and the signal detector constant, especially by a self-enclosed, mechanically rigid structure of one or more substrates, and thereby make it possible to detect and evaluate changes in the transmission properties in the spatial region between the signal source and the signal detector. Such a sensor is especially suited to measure changes in the gas density or in the transport speed or in the throughflow quantity or in the temperature distribution, or the absolute values thereof.

It also proves to be especially advantageous to keep the transmission properties constant in the region between the signal source and the signal detector, and thereby make it possible to measure the distance between the signal source and the signal detector or its change. The transmission properties are here kept constant especially in that the space between the signal source and the signal detector has a uniform and permanent structure. Care must especially be taken to keep the temperature constant, to keep the composition constant, and to make the space isotropic, as well as similar variables. It has proven especially advantageous to fill the space completely with a noble gas or still better with a vacuum. In this case, by comparing the received signal with the information about the emitted signal, information can be obtained about the distance and its change.

A preferred embodiment of the invention comprises a control unit which is connected to the signal source and controls it. Furthermore, the control unit is connected to the evaluation unit, thus updating the information about the signal source for the purpose of evaluating the received physical signals. Furthermore, it is possible, by means of this control unit, to operate the evaluation unit and, as a supplement to this, also the signal detector only for the time during which reception and evaluation of an emitted physical signal by the signal source is expected. This design makes it possible to reduce significantly the electrical consumption of the sensor over an extended period of time, which again opens up a greater field of application, especially in remote measurement stations and especially without a connection to an electrical network.

The evaluation unit and/or the control unit preferably is disposed in the substrate body or bodies, especially in the region of the signal source or of the signal detector, thus achieving a higher integration density of the sensor. This very advantageously affects the size of the sensor. Furthermore, such an arrangement proves electronically very advantageous, since very short signal paths can be realized thereby and thus only minimal signal losses can occur, leading to an especially advantageous signal-to-noise ratio for the received physical signal. Furthermore, such an arrangement proves insensitive to external electronic noise influences, for example through the constantly present electromagnetic smog, which is especially important for application in the automotive field. Such a sensor, with an electronic evaluation unit and/or control unit integrated into the substrate body thus proves especially suitable for use in the automotive field. The control unit preferably is implemented in the substrate body separately from the evaluation unit. The control unit preferably is arranged in the region of the signal source,

Preferably, a sensor with a diaphragm has an additional damping device to damp undesirable vibrations, thus yielding measurement results.

According to a preferred embodiment of the invention, the signal source and/or the signal detector are constructed in such a way that they are suited for space-resolving measurements. This can be done by the signal detector having spatially separated segments, which are activated by the physical signal in a spatially differentiated way, and which are evaluated in a spatially differentiated way by an appropriate electronic apparatus for the space-resolving processing of the received physical signals. This apparatus for space-resolving processing preferably is disposed within the substrate body, and especially below the signal detector in the region of the evaluation unit. This leads to advantages comparable to those of the arrangement of the evaluation unit in the substrate body. This space-resolving measurement and evaluation makes it possible to obtain specific information about the type of excursion of the diaphragm, its mechanical condition, especially its

The control unit of the sensor preferably is connected to the signal source and to the evaluation unit such that the current properties of the signal source are taken into account in the evaluation and thus in the comparison of the emitted physical signal and the expected physical signal with the actually received physical signals. If a change of the properties of the signal source results in a change of the emitted physical signal, for example by a diminished activity of a radioactive radiation source, this information is made available by means of the connecting line of the electronic

Figure 1 shows an inventive sensor for throughflow measurements. The sensor has a first substrate body 1, associated with a second substrate body 2 situated at a distance. The signal source 3 is situated on the first substrate body 1 and faces the second substrate body 2. The signal detector 4 is situated on the second substrate body 2 and faces the first substrate body 1. It is divided into four individual, spatially separated detector elements 4a, 4b, 4c, 4d. An electronic evaluation unit 5 is situated in the interior of the second substrate body 2. It is connected to the individual signal detector elements 4a-4d, and it amplifies and evaluates the received physical signals. This evaluation also comprises a differentiation with respect to the location of the individual signal detector elements, and thus an evaluation with respect to the spatial development of the physical signal. This leads to a representation of the throughflow quantity through the spatial region 6 between the

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In this embodiment, the signal source 3 operates completely independently of the signal detector 4 and of the evaluation unit 5. Consequently, it is also not necessary to connect the signal detector 3 electrically to the signal detector 4 or to the evaluation unit 5. This is especially advantageous since it essentially excludes all problems associated with sealing electrical connections against the flowing measurement substance and thus excludes the risk of malfunction or total failure of the sensor.

The construction of the sensor with the two substrate bodies 1, 2 and the signal source 3 and signal detector 4, together with the integrated evaluation unit 5, situated thereon create an extremely small sensor structure. It can thus also be used in situations where, for example, only small amounts of substance are present, whose throughflow rate or throughflow quantity is to be measured. Such a throughflow quantity sensor proves to be especially suitable for the pharmaceutical industry or for test laboratories, prototype laboratories and analytical laboratories of the chemical industry.

Figure 2 shows an inventive pressure sensor comprising a first substrate body 1 and a second substrate body 2, such that a signal detector 4 is situated on the second substrate body 2 and an electronic evaluation unit 5 is integrated into the second substrate body 2, so as to process the physical measurement signals. Integrating the evaluation device 5 into the substrate body 2 directly at the signal detector 4 utilizes the available space for the entire sensor very efficiently. Furthermore, the signal paths from the signal detector 4 to the evaluation unit 5 are considerably shortened, resulting in an especially reliable evaluation of the measurement signals. The first substrate body 1 is formed in such a way that it has a diaphragm which can be deformed by pressure. Usually the pressure is exerted on the membrane in the direction of the arrow. A signal source 3 is situated in the area of the diaphragm, on that side which is associated with the signal detector 4. If the diaphragm is deformed through the action of an external pressure, the signal source 3 is thereby changed in its position, and this causes its distance from the signal detector 4 to change. If the physical signal emitted by the signal source 3 has a dependence on the distance it traverses before being received by the signal detector 4, information about the traversed path and thus about the distance between the signal source 3 and the signal detector 4 can be obtained from the evaluation of the received physical signal by the evaluation unit 5. Information thus can be obtained about the pressure exerted on the diaphragm. This information can relate both to the relative pressure and absolute pressure.

In the chosen embodiment, the substrate bodies 1, 2 are made of silicon. This makes integration of the evaluation unit 5 especially simple. In addition, silicon has especially advantageous mechanical properties for the deformable diaphragm 5. The signal source 3 and the signal detector 4 are formed on their respective substrate bodies 1, 2, by conductor tracks with a specific shape and size

The sensor has a control unit 7, which is connected to the transmission source 3 by a control line, and actuates said transmission source to emit a certain physical signal at a specific time. Furthermore, the control

unit 7, which preferably is integrated in the substrate body 1 close to the signal source 3, is connected to the signal detector 4. The evaluation unit 4 is integrated into the second substrate body 2, which is associated with the signal detector 4. By means of the connecting lines to the signal detector 4 and to the evaluation unit 5, these are switched on specifically in knowledge of the control data of the signal source and the expected reception time of the physical signal. This guarantees that the signal detector 4 will detect the physical signal emitted by the signal source 3 and that the evaluation unit 5 will make an appropriate evaluation. Outside this time window, necessary for reliable operation, the signal detector 4 or also the evaluation unit 5 is turned off, thus significantly reducing the energy consumption of the sensor over time. The like also holds for the signal source 3.

The evaluation unit 5 is connected to the control unit 7 and the signal detector 4, through which connection the received physical signal is conducted to the evaluation unit 5. However, it is also connected to an external display 9. The measurement variables measured by the evaluation unit 5, such as pressure, force, acceleration, throughflow rate, throughflow quantity, temperature, or the like, are displayed to the user on this display unit.

List of Reference Symbols

- 1 First substrate body
- 2 Second substrate body
- 3 Signal source
- 4 Signal detector
- 5 Evaluation unit
- 6 Spatial region
- 7 Control unit
- 8 Display

1. A sensor comprising a signal source (3) to emit a physical signal and a signal detector (4) at a distance from the signal source (3), to receive the physical signal at the location of the signal detector, and an evaluation unit (5), which is connected to the signal detector (4) and which evaluates the received physical signal and which from this determines the relative distance between the signal source (3) and the signal detector (4), such that the signal source (3) and the signal detector (4) are situated on a common substrate body (1) or on two mutually separated substrate bodies (1, 2).
2. The sensor of Claim 1, characterized in that the evaluation is performed in terms of stored information regarding the transmission source (3).
3. The sensor of Claim 1 or 2, characterized in that the spatial distance between the signal source (3) and the signal detector (4) is constant, and the spatial region (6) between these can undergo a change of its transmission property.
4. The sensor of Claim 1 or 2, characterized in that the spatial distance between the signal source (3) and the signal detector (4) is variable, and the spatial region (6) between these does not undergo a change of its transmission properties.
5. The sensor of Claim 3, characterized in that the evaluation unit (5) is designed in such a way that the gas density or transport rate or throughflow quantity can be determined from the relative distance.

6. The sensor of Claim 4, characterized in that the evaluation unit is designed so that the acceleration, pressure, or force on the sensor can be determined from the relative distance.
7. The sensor of one of the preceding claims, characterized in that the control unit (7) is connected to the signal source (3) and controls it, and that the evaluation unit (5) is connected to the control unit (7) in such a way that, by means of the control data received from the control unit (7), the information regarding the signal source (3) can be updated.
8. The sensor of one of the preceding claims, characterized in that the control unit (7) is connected to one or more of the following units: signal source (3), the signal detector (4), and the evaluation unit (5), in such a way that these can be turned off and turned on in a specific way by the control unit (7).
9. The sensor of one of the preceding claims, characterized in that the evaluation unit (5) and/or the control unit (7) is integrated into at least one of the substrate bodies (1, 2).
10. The sensor of Claim 9, characterized in that the evaluation unit (9) is situated in the substrate body (2) below the signal detector (4).
11. The sensor of Claim 9 or 10, characterized in that the evaluation unit (5) is integrated into the second substrate body (2) and the control unit (7) is integrated into the first substrate body (1).
12. The sensor of one of the preceding Claims 9 to 11, characterized in that the evaluation unit (5) and/or the control unit (7) have elements which amplify the signal.



PCT

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INTERNATIONALE ANMELDUNG VERÖFFENTLICHT NACH DEM VERTRAG ÜBER DIE
INTERNATIONALE ZUSAMMENARBEIT AUF DEM GEBIET DES PATENTWESENS (PCT)

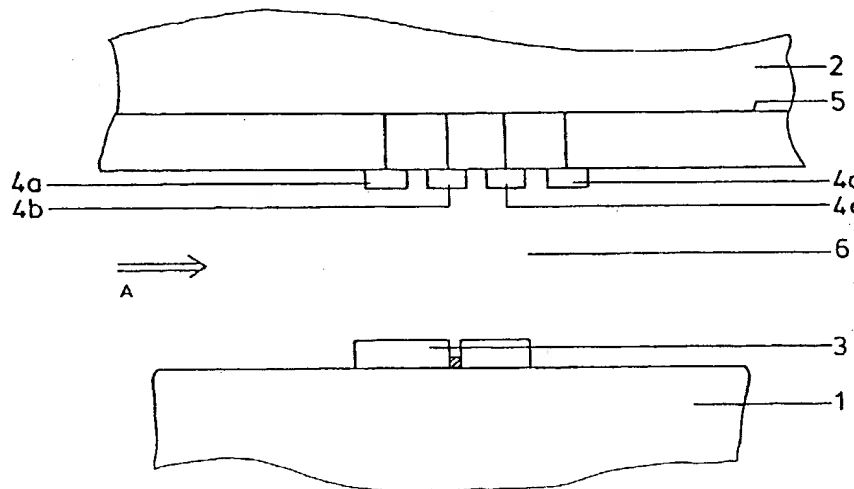
(51) Internationale Patentklassifikation ⁷ : G01L 1/24, 11/02, G01B 11/02, G01L 9/00		A1	(11) Internationale Veröffentlichungsnummer: WO 00/37910
		(43) Internationales Veröffentlichungsdatum:	29. Juni 2000 (29.06.00)
(21) Internationales Aktenzeichen: PCT/EP99/09882		(81) Bestimmungsstaaten: JP, US, europäisches Patent (AT, BE, CH, CY, DE, DK, ES, FI, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE).	
(22) Internationales Anmeldedatum: 14. Dezember 1999 (14.12.99)		Veröffentlicht <i>Mit internationalem Recherchenbericht.</i>	
(30) Prioritätsdaten: 198 58 827.5 19. Dezember 1998 (19.12.98) DE			
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(54) Title: SENSOR

(54) Bezeichnung: SENSOR

(57) Abstract

The invention relates to a sensor having a signal source for emitting a physical signal and a signal detector mounted at a distance from said signal source for receiving the physical signals in the location of the signal detector. The physical signal received is evaluated with the aid of an evaluation unit in which the physical signal received is evaluated on the basis of information stored pertaining the signal source. The relative distance between the signal source and the signal detector is determined on the basis of said evaluation. Relative distance includes the geometric distance between the signal source and the signal detector and the transmission characteristics of the area between the signal source and the signal detector. When one of said parameters is maintained constant, conclusions regarding other parameters may be drawn and indications on given physical variables may be given. Said sensor may be used as an acceleration, pressure, power, gas density, transport speed or flow rate sensor.



Said sensor may be used as an acceleration, pressure, power, gas density, transport speed or flow rate sensor.

FIG 1

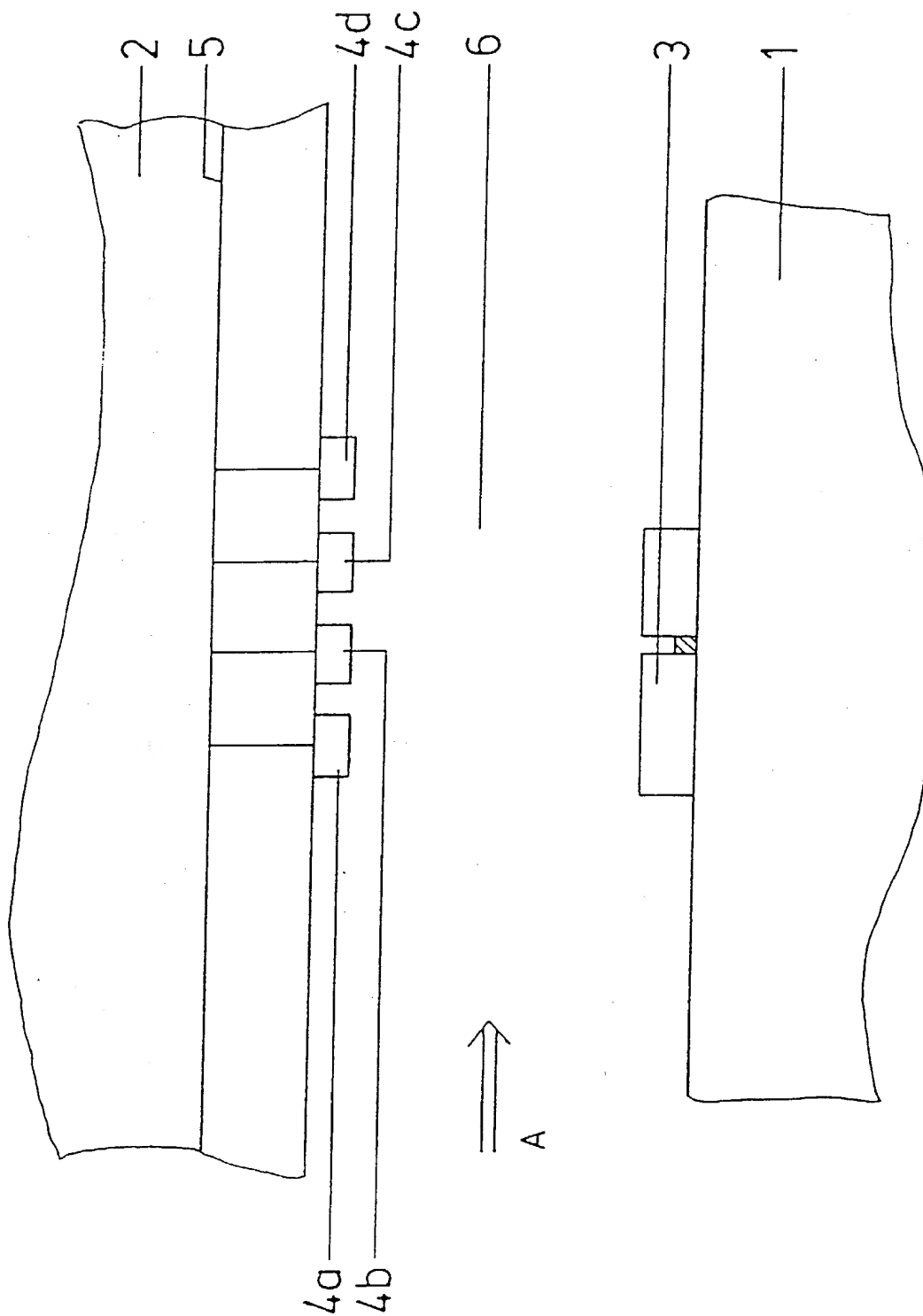


FIG 2

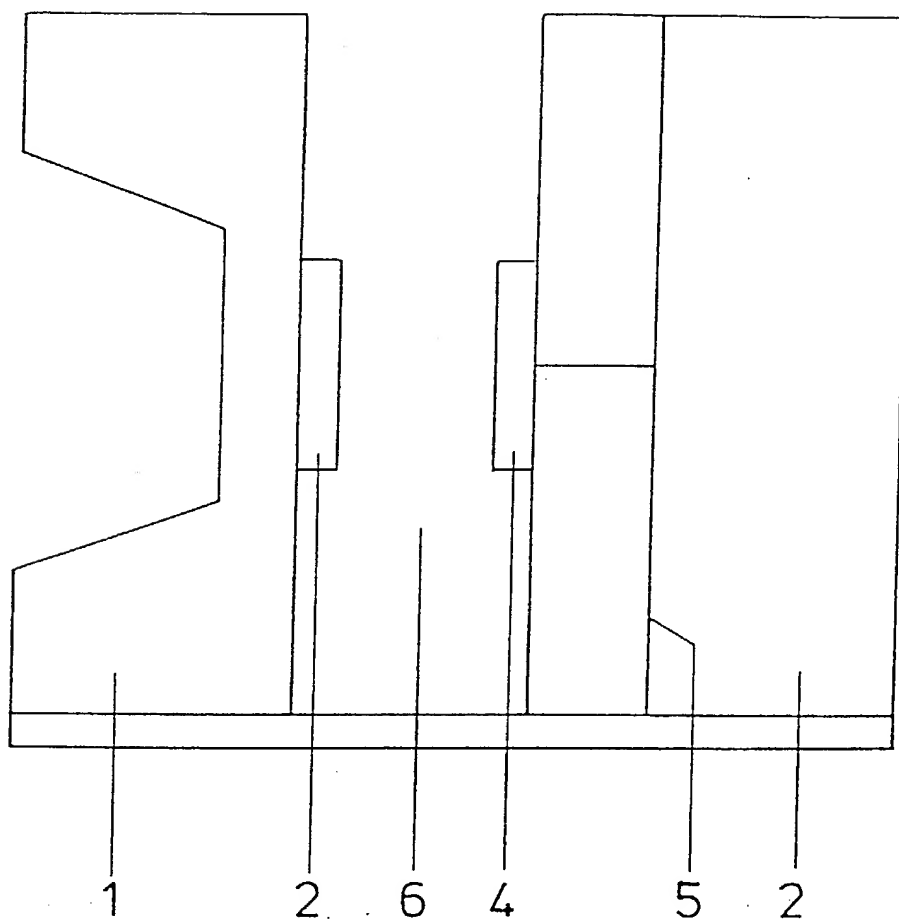
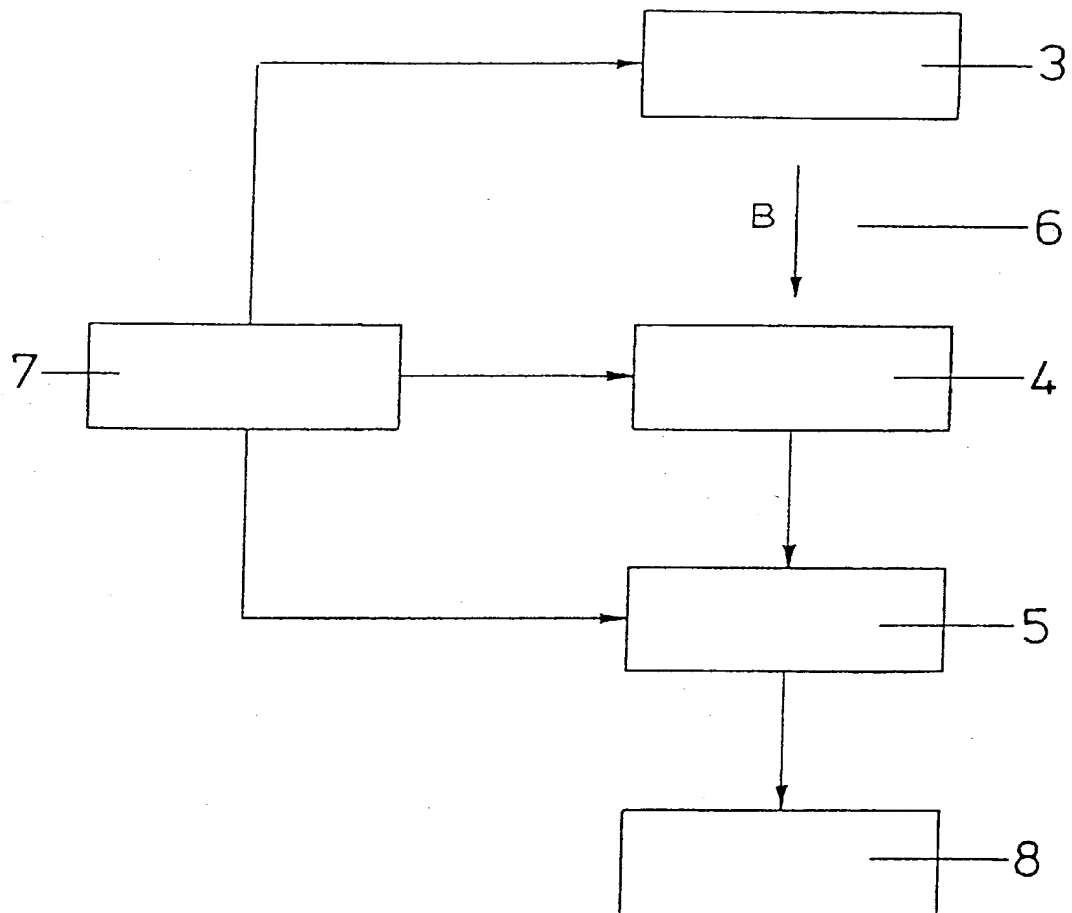


FIG 3



Docket No: Mic.6222

DECLARATION AND POWER OF ATTORNEY

We, the below named inventors, hereby declare that:

Our residences, post office addresses, and citizenships are as stated below next to our respective names.

We believe we are the original, first, and joint inventors of the subject matter which is claimed and for which a patent is sought on the invention entitled SENSOR, filed with the United States Patent and Trademark Office on May 31, 2001 and designated Serial No. 09/857,285.

We hereby state that we have reviewed and understand the contents of the above-identified specification, including the claims.

We acknowledge the duty to disclose information which is material to patentability in accordance with Title 37, Code of Federal Regulations, Section 1.56.

We hereby claim foreign priority benefits under Title 35, United States Code §119(a)-(d) or §365(b) of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate filed by us on the same subject matter having a filing date before that of the application(s) on which priority is claimed: German Patent Application No. 198 58 827.5 filed December 19, 1998, and International Application No. PCT/EP99/09882 filed December 14, 1999.

We hereby declare that all statements are made hereby of our own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

And we hereby appoint:

Maurice E. Gauthier	-	Reg. No. <u>20,798</u>
Richard L. Stevens	-	Reg. No. <u>24,445</u>
Matthew E. Connors	-	Reg. No. <u>33,298</u>
William E. Hilton	-	Reg. No. <u>35,192</u>
Patrick J. O'Shea	-	Reg. No. <u>35,305</u>
Arlene J. Powers	-	Reg. No. <u>35,985</u>
Richard J. Stevens, Jr.	-	Reg. No. <u>44,357</u>
Peter Stecher	-	Reg. No. <u>47,259</u>

all of the firm of Samuels, Gauthier & Stevens, our attorneys with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

We request that all correspondence be directed to:

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